

Message Text

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PAGE 01 OECD P 15249 130945Z

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ACTION EB-07

INFO OCT-01 CIAE-00 COME-00 DODE-00 NSAE-00 TRSE-00 EUR-12

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FM USMISSION OECD PARIS

TO SECSTATE WASH DC 7526

C O N F I D E N T I A L OECD PARIS 15249

EXCON

E.O. 11652 XGDS1

TAGS: ESTC, COCOM

SUBJECT: COCOM LIST REVIEW: IL 1355 - SEMICONDUCTOR MANU-
FACTURING MACHINERY

REFS: A. COCOM DOC REV (74) 1355/2

B. STATE 135219

1. USDEL MET JUNE 11 WITH UK, CANADIAN, JAPANESE, FRENCH, AND GERMAN REPS IN A TWG WHICH WENT OVER REF A PROPOSAL IN DETAIL. ONLY GERMANS HAD INDUSTRY EXPERT, ULRICH OF SIEMENS, WHO FREQUENTLY WAS ABLE TO OFFER ON-THE-SPOT CLARIFICATIONS GENERALLY SUPPORTING REFD. MCCOLLOUGH OF UK ACTED AS CHAIRMAN AND US AS RAPORTEUR. IT WILL TAKE SOME WHILE TO TRANSCRIBE OUR DETAILED NOTES, BUT WE WILL SEND REPORT BY POUCH AS SOON AS POSSIBLE.

2. WE WILL LEAVE IT TO THE SECRETARIAT'S RECORD TO REPORT IN DETAIL ON FULL COMMITTEE DISCUSSION OF JUNE 12. AGAIN, ITALY STATED THAT ITS PROPOSAL REMAINED CURRENT AND REQUESTED US VIEWS. EXCEPT FOR THE GERMANS AND JAPANESE, WHO INDICATED APPROVAL IN PRINCIPLE OF US PROPOSAL, MOST OTHER DELEGATIONS TOOK GENERALLY NEGATIVE VIEW. CANADIAN WAS OPEN MINDED BUT STRESSED HIS AUTHORITIES WOULD NOT WISH TO SEE ANY INCREASE OF EMBARGO. FRENCH ATTITUDE DEPENDED ON EXTENT TO WHICH US COULD ACCOMMODATE.
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PAGE 02 OECD P 15249 130945Z

DATE A NUMBER OF PROBLEMS THEY HAD WITH REFD. C

WORDING (EXPECTABLY, PRIMARILY IN THE TEST EQUIPMENT AREA), AND BELGIUM GAVE NO VIEW. UK, ITALY (OFF THE RECORD), AND NETHERLANDS ALL INDICATED THAT THEY FOUND THE PRESENT DEFINITION BETTER THAN THAT SUGGESTED BY US, BUT, OF COURSE, WOULD PREFER ACCEPTANCE OF THE AMENDMENTS SUGGESTED BY OTHER DELS IN ROUND I.

3. IN ONLY TECHNICAL DEVELOPMENT OF SIGNIFICANCE AT FULL COMMITTEE MEETING, GERMAN DEL SUGGESTED THAT US PROPOSAL WOULD BE BETTER, AND EASIER FOR LICENSING OFFICIALS TO ADMINISTER, IF EQUIPMENT TO BE EMBARGOED WERE GROUPED BY FUNCTION, I.E., (A) MASK DESIGN AND PRODUCTION; (B) WAFER PROCESSING; (C) ASSEMBLY; (D) TESTING. FRENCH AND UK (LATTER WITHOUT COMMITTMENT TO EVENTUAL POSITION) AGREED WITH UTILITY OF GERMAN SUGGESTION.
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Message Attributes

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